

CHEMICAL SENSORS FOR AEROSPACE APPLICATIONS

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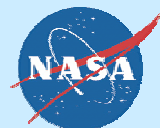
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The Ohio State University
Columbus, Ohio, USA 43210

D. Makel, S. Carranza and B. Ward
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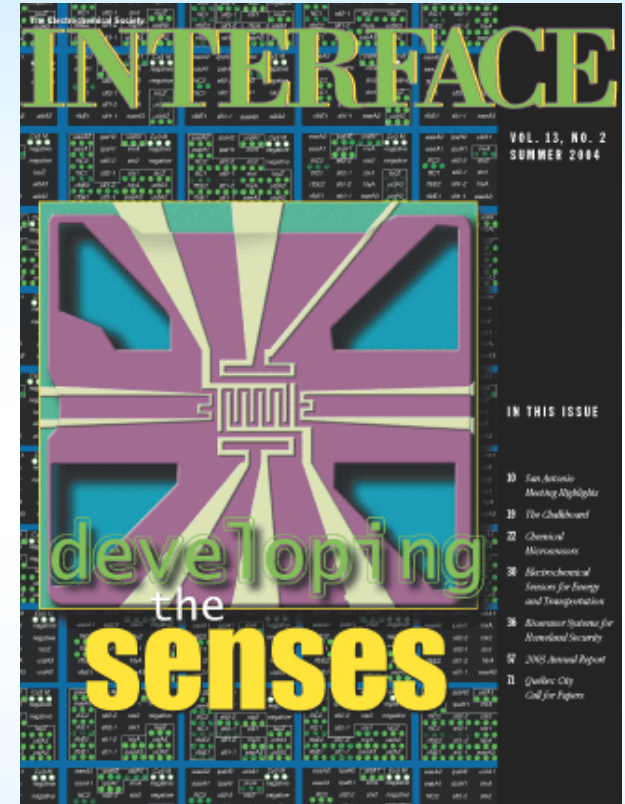
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OUTLINE

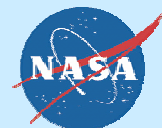
- INTRODUCTION
- MICROFABRICATED GAS SENSORS
- SENSOR DEVELOPMENT
 - HYDROGEN
 - CARBON MONOXIDE AND NITROGEN OXIDES
 - HYDROCARBONS
 - OXYGEN
- LEAK DETECTION
- HIGH TEMPERATURE ELECTRONIC NOSE
- FIRE DETECTION
- SUMMARY AND FUTURE PLANS



NASA GRC/CWRU O2 Sensor Featured
On the Cover of the Electrochemical Society
Interface Magazine

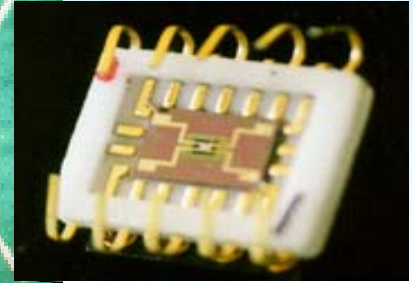
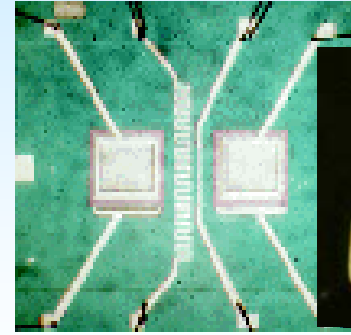
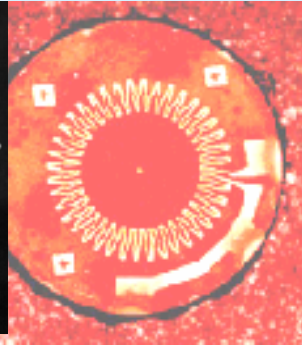
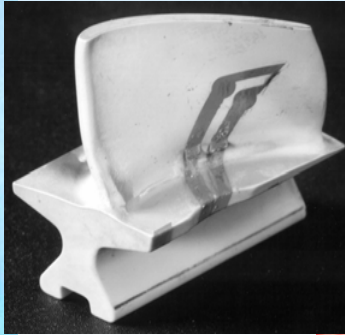
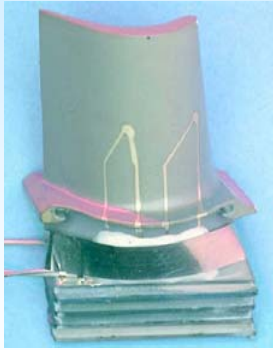
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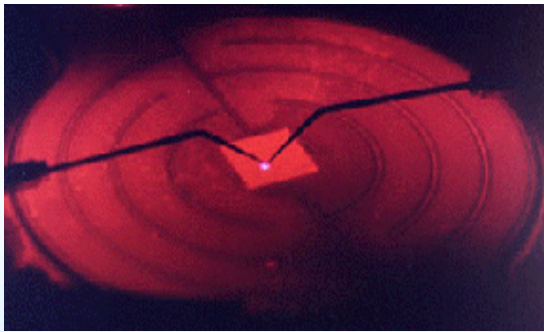
SENSORS AND ELECTRONICS TECHNOLOGY BRANCH

SCOPE OF WORK

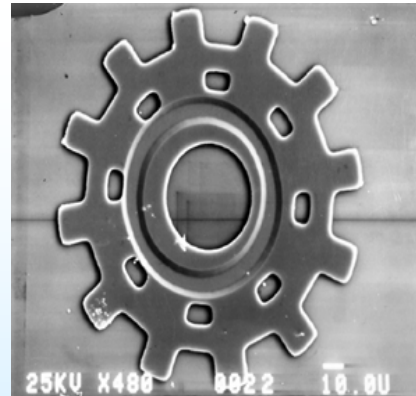


PHYSICAL SENSORS (T, Strain, Heat Flux)

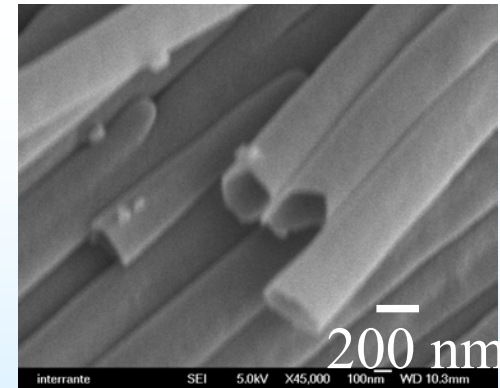
CHEMICAL SENSORS



**SILICON CARBIDE HIGH
TEMP ELECTRONICS**



**MICRO-ELECTRO-
MECHANICAL SYSTEMS**

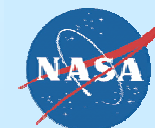


NANOTECHNOLOGY



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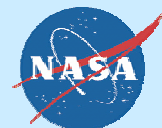
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MICROFABRICATED GAS SENSORS



- **COLLABORATIVE EFFORT BETWEEN NASA GRC, CASE WESTERN RESERVE, and OHIO STATE UNIVERSITY**
- **SENSOR DEVELOPMENT RESULTING FROM:**
 - IMPROVEMENTS IN MICROFABRICATION AND MICROMACHINING TECHNOLOGY**
 - NANOMATERIALS**
 - DEVELOPMENT OF SiC-BASED SEMICONDUCTOR TECHNOLOGY**
- **GAS DETECTION IN:**
 - HARSH ENVIRONMENTS**
 - APPLICATIONS BEYOND CAPABILITIES OF COMMERCIAL SENSORS**
- **TECHNOLOGY DEVELOPS PLATFORMS FOR A VARIETY OF MEASUREMENTS**
 - SCHOTTKY DIODE**
 - RESISTANCE BASED**
 - ELECTROCHEMICAL**
- **TARGET DETECTION OF GASES OF FUNDAMENTAL INTEREST**
 - HYDROGEN (H₂)**
 - HYDROCARBONS (C_xH_y)**
 - NITROGEN OXIDES (NO_x) AND CARBON MONOXIDE (CO)**
 - OXYGEN (O₂)**
 - CARBON DIOXIDE (CO₂)**



CHEMICAL SENSOR APPLICATION DEVELOPMENT AREAS

SAFETY

LEAK DETECTION

DETECTION OF FUEL AND OXYGEN LEAKS FOR SPACE TRANSPORTATION APPLICATIONS SUCH AS SPACE SHUTTLE, X-43 AND NEXT GENERATION LAUNCH TECHNOLOGY. WIDE RANGE DETECTION IN INERT ENVIRONMENTS AND POSSIBLY CRYOGENIC CONDITIONS.

FIRE DETECTION

DETECTION OF FIRE PRECURSORS (E.G. CO AND CO₂) IN CARGOBAY APPLICATIONS TO SUPPLEMENT EXISTING TECHNOLOGY. CHEMICAL SIGNATURE IN THE PRESENCE OF A NUMBER OF INTERFERING GASES. COMPLEMENT EXISTING SMOKE DETECTION SYSTEMS.

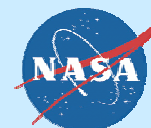
EMISSIONS

DETECTION OF HYDROCARBONS, NO_x, CO, ETC. FOR HEALTH MONITORING AND ACTIVE COMBUSTION CONTROL APPLICATIONS. SENSITIVE DETECTION IN HIGH TEMPERATURE HARSH ENVIRONMENTS IN THE PRESENCE OF A NUMBER OF INTERFERING GASES.

ENVIRONMENTAL MONITORING/BIO

DETECTION OF HYDRAZINE FOR ISS/EVA APPLICATIONS

DETECTION OF NO_x/CO FOR ASTHMA MONITORING



BASE PLATFORM SENSOR TECHNOLOGY

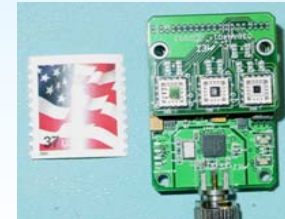
Integration of Micro Sensor Combinations
into Small, Rugged Sensor Suites

Example Applications: AEROSPACE VEHICLE FIRE, FUEL, EMISSIONS,
ENVIRONMENTAL MONITORING CREW HEALTH, SECURITY

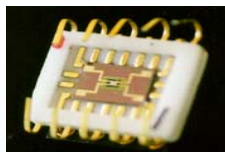
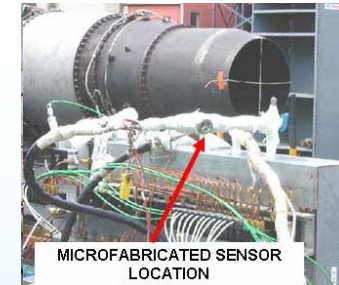
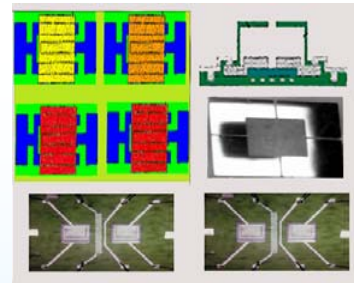
Multi Species Fire Sensors
for Aircraft Cargo Bays



“Lick and Stick” Space Launch Vehicle
Leak Sensors with Power and Telemetry



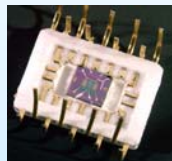
Aircraft Propulsion Exhaust High
Temperature Electronic Nose



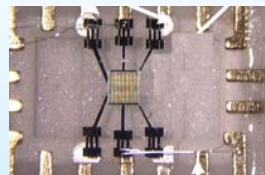
Oxygen Sensor



SiC Hydrocarbon
Sensor



H2 Sensor



Nanocrystalline Tin
Oxide NOx and CO
Sensor



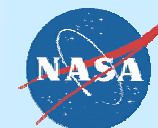
Sensor Equipped
Prototype Medical
Pulmonary Monitor



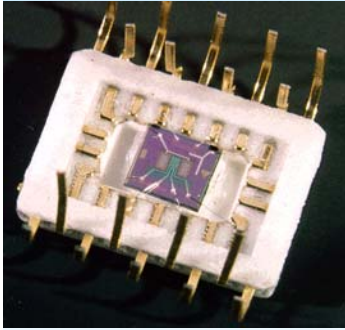
Hydrazine EVA Sensors
(11 ppb Detection)

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HYDROGEN LEAK SENSOR TECHNOLOGY: MEMS APPLIED IN SPACE AND COMMERCIAL APPLICATIONS



- MICROFABRICATED USING MEMS-BASED TECHNOLOGY FOR MINIMAL SIZE, WEIGHT AND POWER CONSUMPTION
- HIGHLY SENSITIVE IN INERT OR OXYGEN-BEARING ENVIRONMENTS, WIDE CONCENTRATION RANGE DETECTION

1995 R&D 100 AWARD WINNER

NASA 2003 TURNING GOALS INTO REALITY SAFETY AWARD

Shuttle



X33



X43



Helios



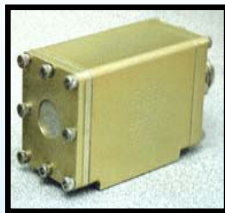
IIS



Model U



Aft Compartment Hydrogen Monitoring



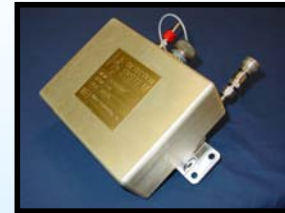
Hydrogen Safety Monitoring



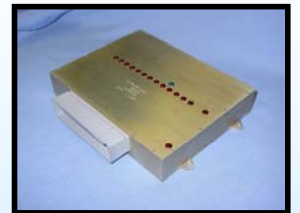
Hydrogen Safety Monitoring



Fuel Cell Safety and Process Monitoring



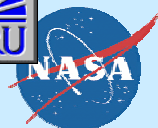
Life Support Process and Safety Monitoring



Vehicle Safety Monitoring

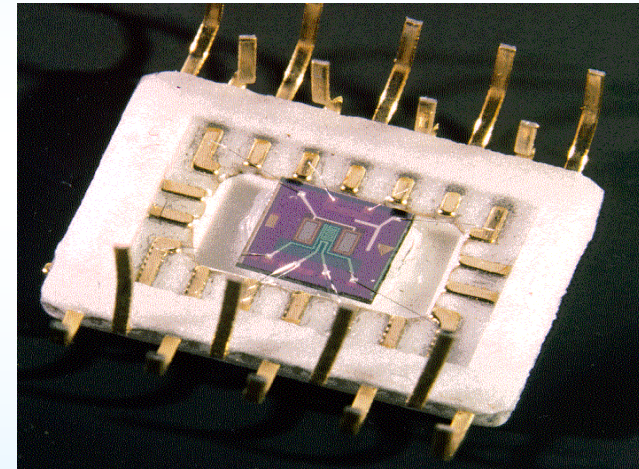
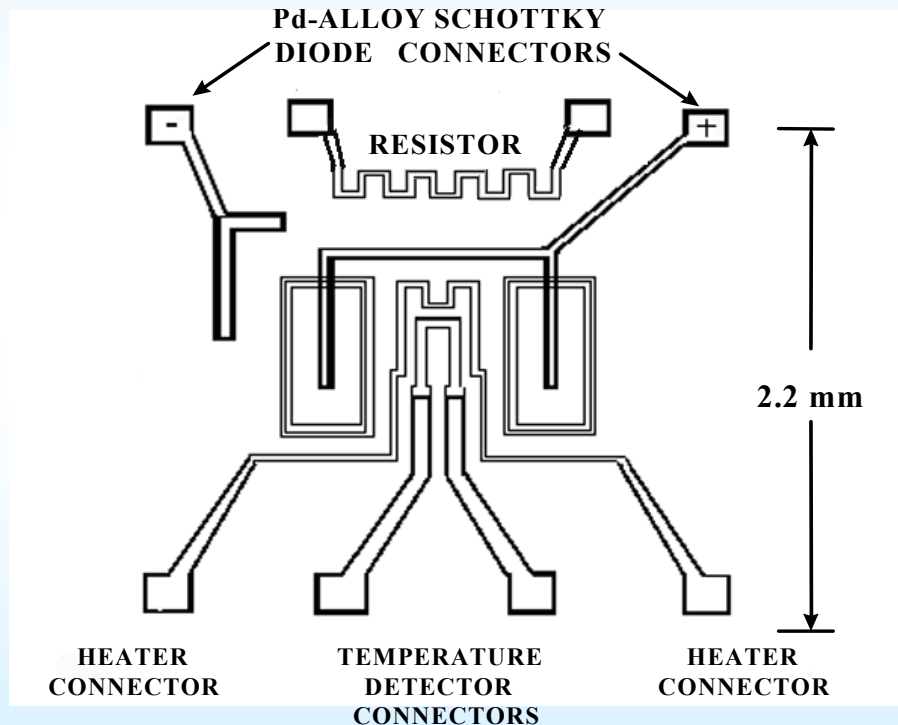
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MEI Makel Engineering Inc.



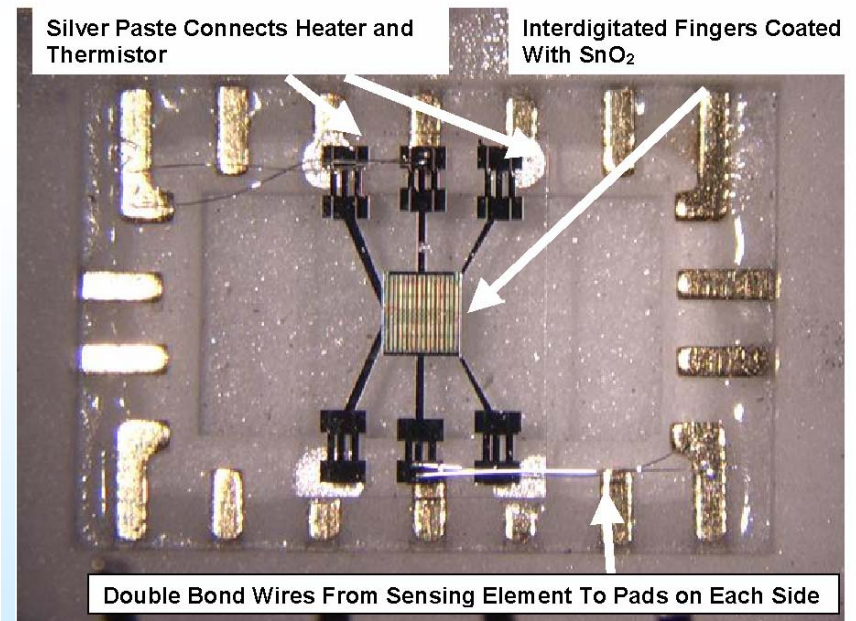
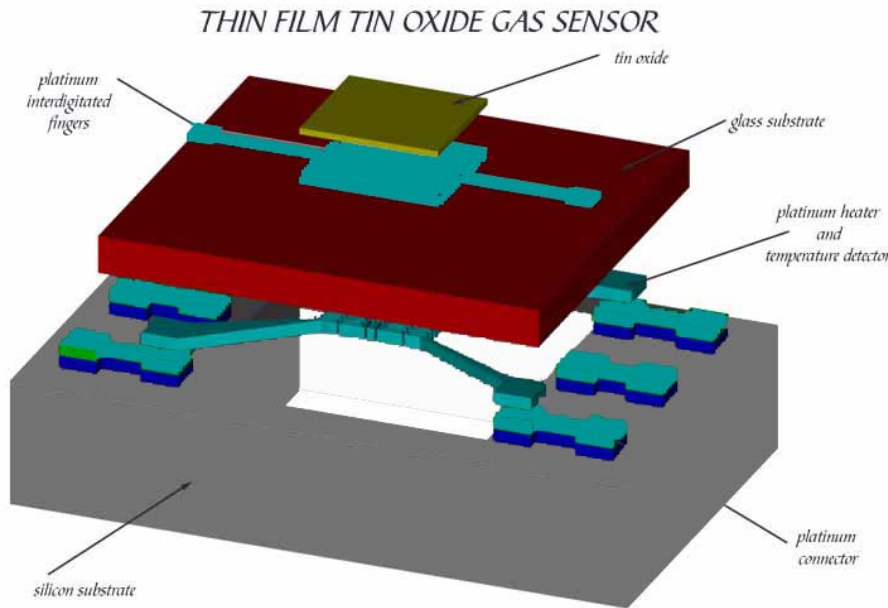
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WIDE CONCENTRATION RANGE HYDROGEN SENSOR DESIGN

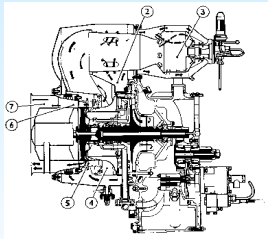


MICROFABRICATED TIN OXIDE BASED NO_x AND CO SENSOR TECHNOLOGY

- MICROFABRICATED FOR MINIMAL SIZE, WEIGHT AND POWER CONSUMPTION
- MICROMACHINED TO MINIMIZE POWER CONSUMPTION AND IMPROVE RESPONSE TIME
- TEMPERATURE DETECTOR AND HEATER INCORPORATED INTO SENSOR STRUCTURE
- NANOFABRICATION OF TIN-OXIDE TO INCREASE SENSOR STABILITY



DEMONSTRATION TESTING OF NANOCRYSTALLINE NO_x SENSOR IN GAS TURBINE EXHAUST STREAM

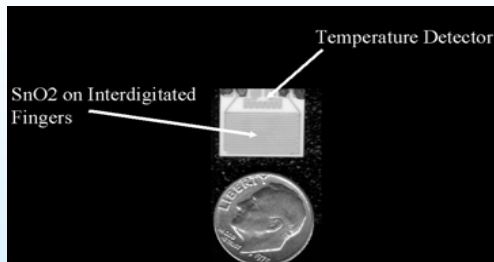


50 Hp Gas Turbine

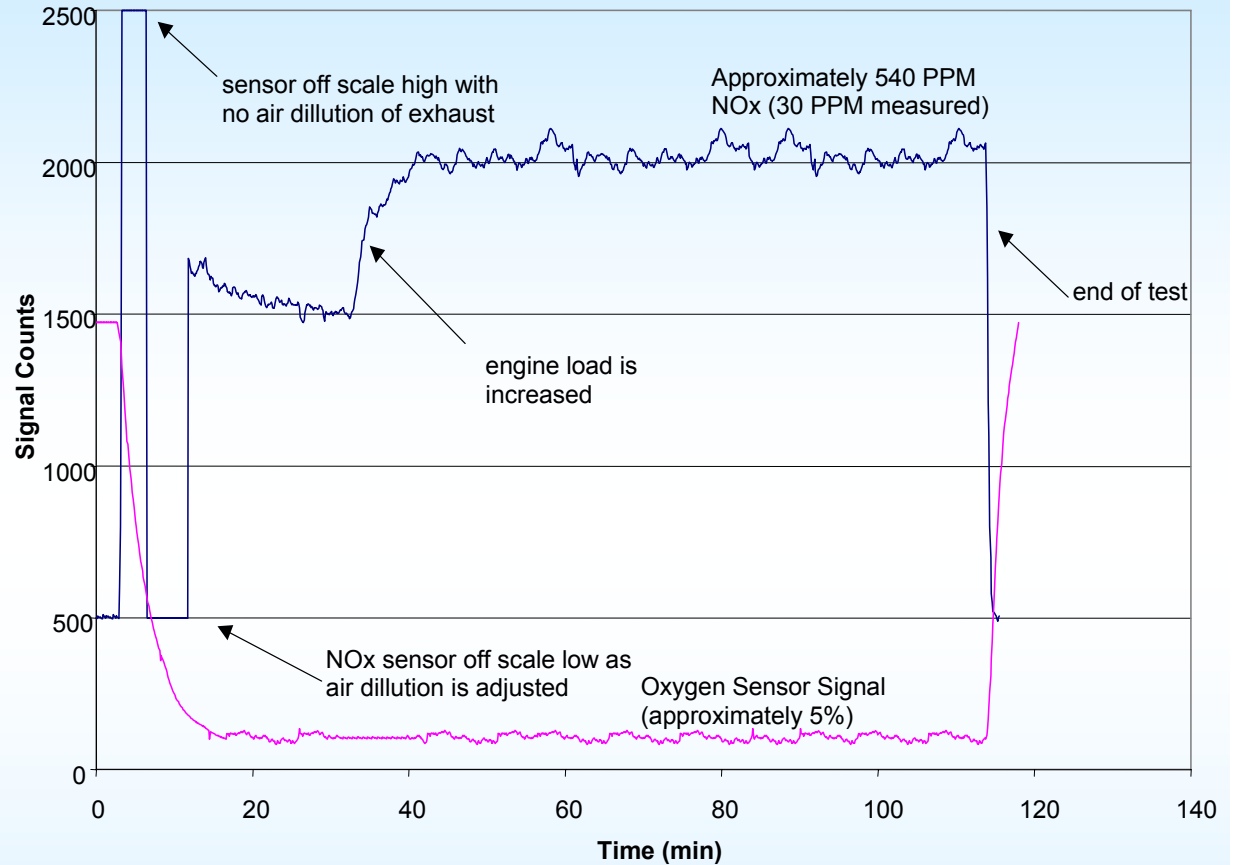


Industry Standard Continuous Emission Monitoring Equipment

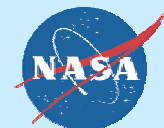
REPLACE INSTRUMENT RACK SIZED SYSTEM WITH DIME SIZED SENSOR AND ACCOMPANYING ELECTRONICS



Makel Engineering, Inc.



Species	CEM Measurement	MSES Measurement
NO _x	593 PPM	540 PPM
CO	3000 PPM	N/A
O ₂	4.57%	5%



SiC-BASED GAS SENSOR DEVELOPMENT



- THE USE OF SiC SEMICONDUCTORS ALLOWS SENSOR OPERATION AT TEMPERATURES WHICH ALLOW THE DETECTION OF HYDROCARBONS AND NO_x
- SCHOTTKY DIODE DESIGN FOR HIGH SENSISTIVITY
- TEMPERATURE DETECTOR AND HEATER INCLUDED

OPERATION AT A RANGE OF TEMPERATURES

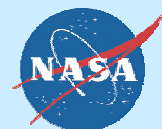
- WIDE RANGE OF APPLICATIONS
EMISSION MONITORING
ENGINE HEALTH MONITORING
ACTIVE COMBUSTION CONTROL
HYDROCARBON FUEL LEAK DETECTION
FIRE SAFETY

- PROTOTYPE SENSOR PACKAGE FABRICATED

- TWO APPROACHES

ALLOY ON SiC SUBSTRATE
REACTIVE INSULATOR APPROACH

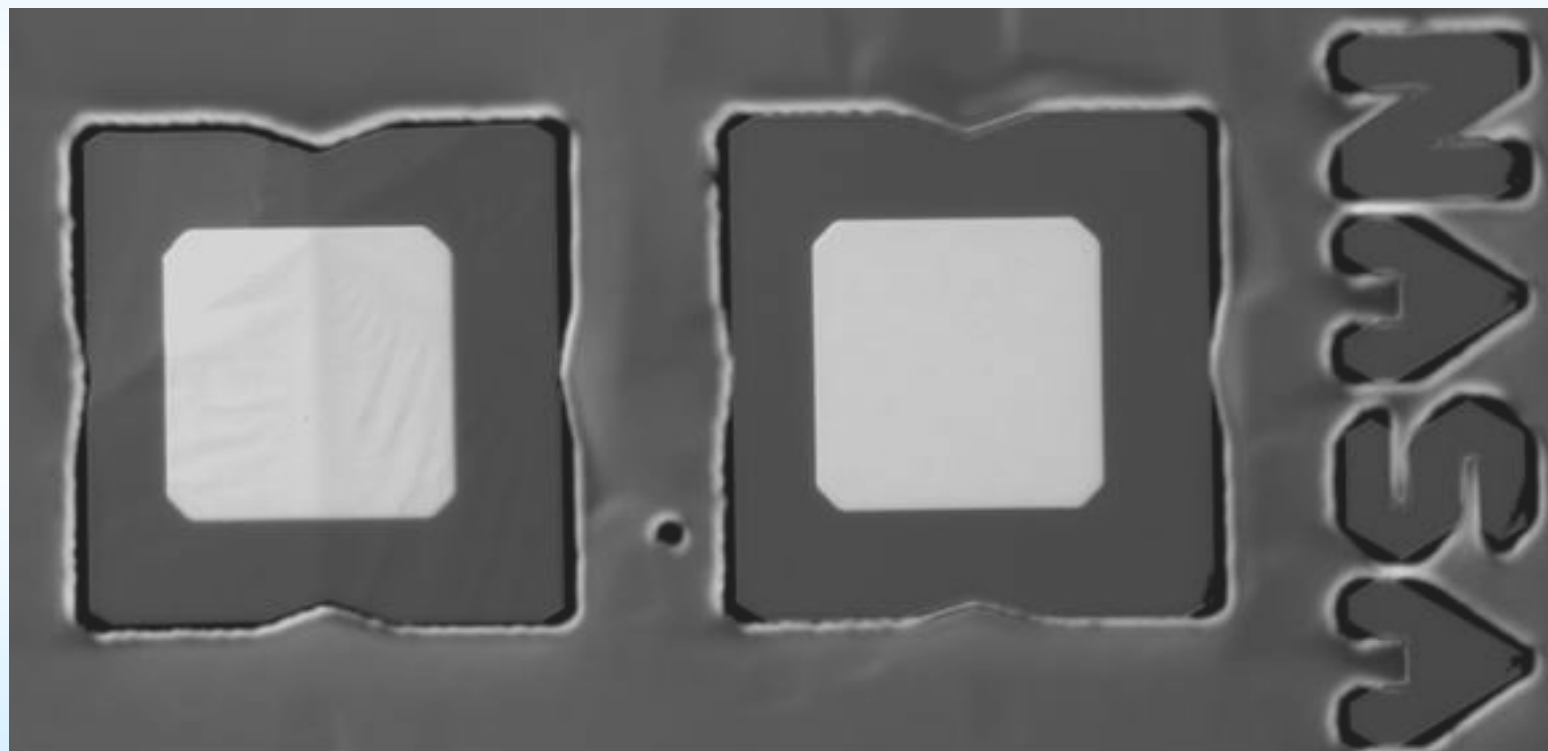
PACKAGED SiC-BASED SENSOR



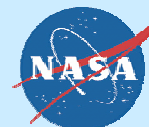
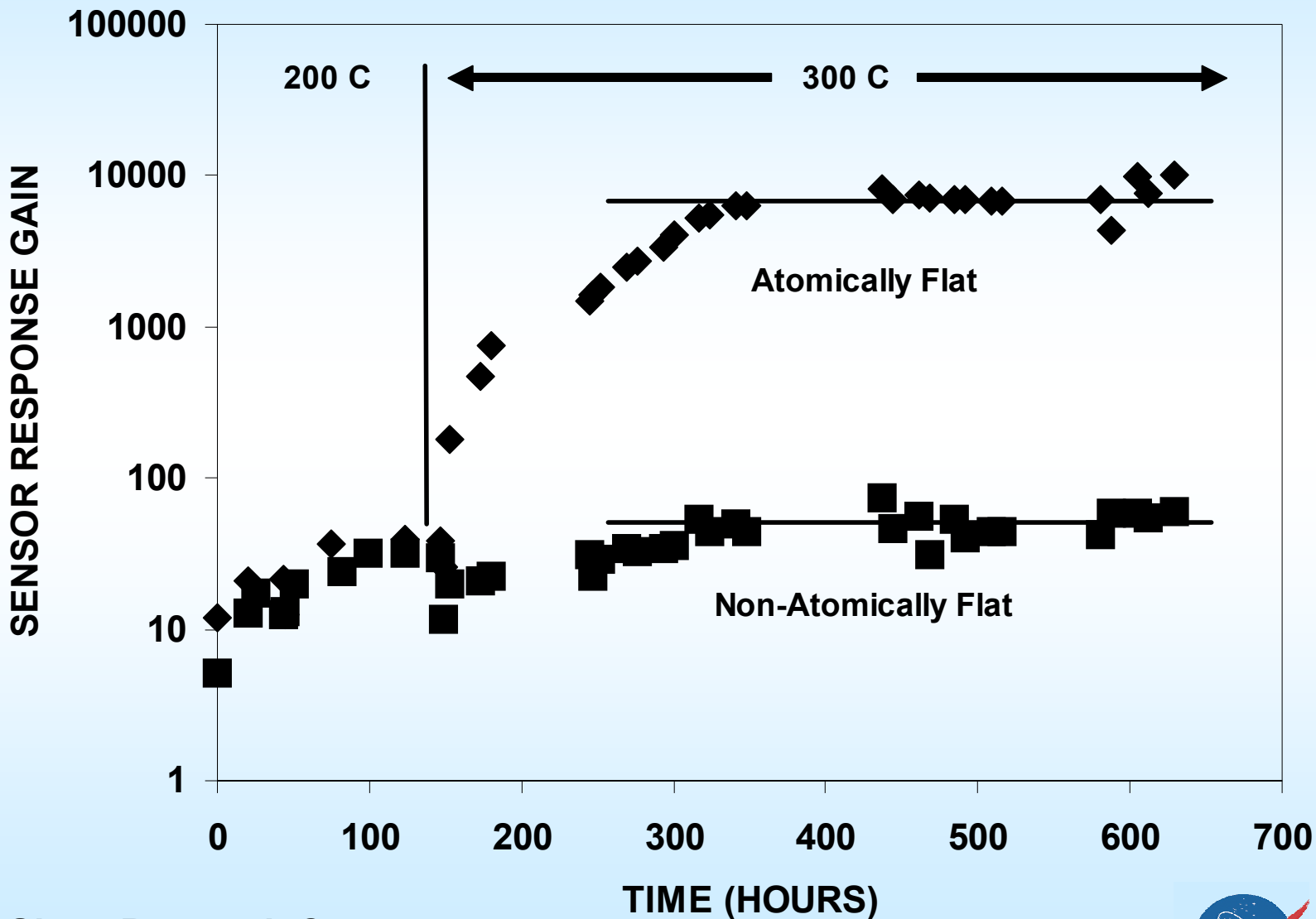
Pt/SiC SCHOTTKY DIODES TESTED SIDE BY SIDE ON SAME CHIP: ATOMICALLY FLAT AND NON-ATOMICALLY FLAT

Non-Atomically Flat

Atomically Flat



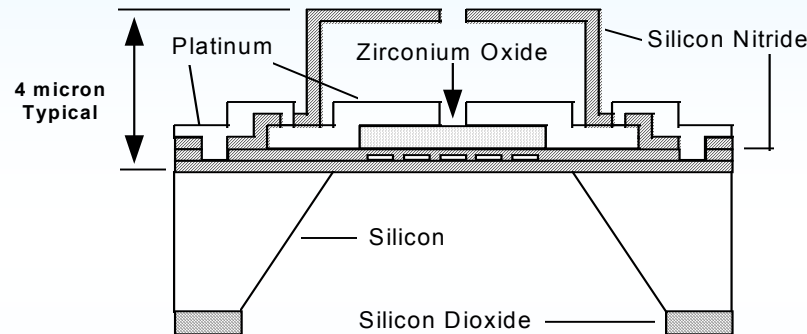
COMPARISON OF SENSOR GAIN TO 0.5% HYDROGEN BETWEEN Pt/SiC SENSORS DEPOSITED ON ATOMICALLY FLAT SiC (♦) AND NON-ATOMICALLY FLAT SiC (■).



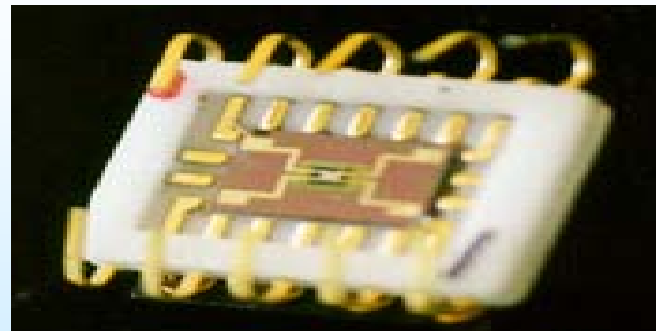
MICROFABRICATED OXYGEN SENSOR TECHNOLOGY



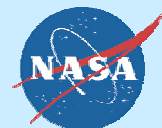
- MICROFABRICATED AND MICROMACHINED FOR MINIMAL SIZE, WEIGHT AND POWER CONSUMPTION (LESS THAN 2 W FOR 600 C OPERATION)
- AMPEROMETRIC OPERATION ALLOWS MEASUREMENT OF OXYGEN OVER A WIDE CONCENTRATION RANGE (0-100%)
- CHAMBER STRUCTURE CONTROLS OXYGEN DIFFUSION RATE
- INCORPORATION OF OXYGEN SENSOR WITH OTHER SENSORS (E.G. HYDROGEN) IN THE SAME PACKAGE PLANNED



Not to scale:



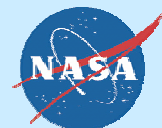
ZrO₂ Oxygen Sensor



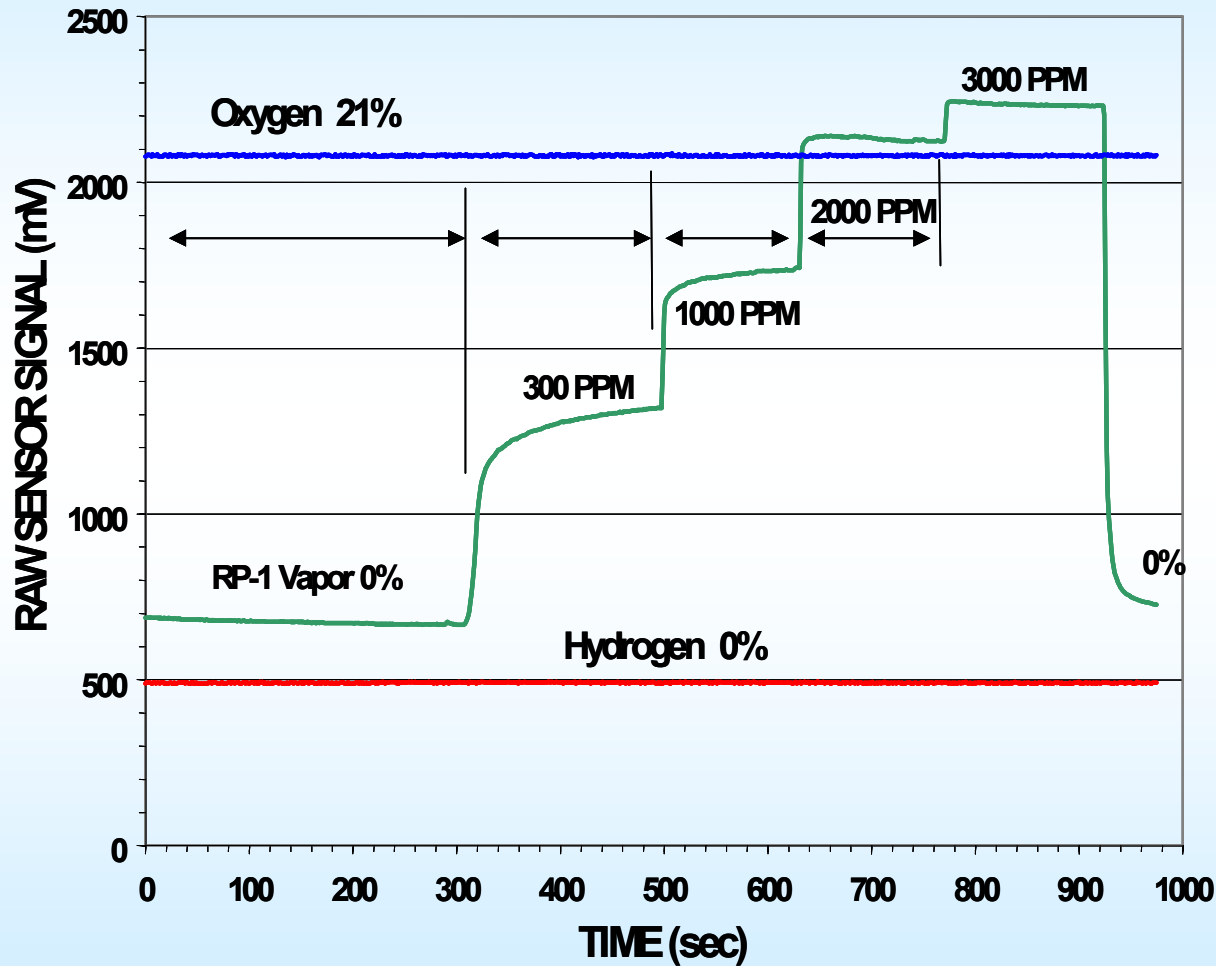
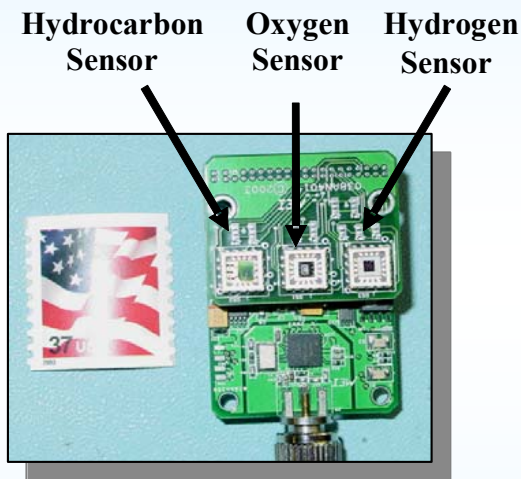
SENSOR SYSTEM DEVELOPMENT

- EACH SENSOR PLATFORM PROVIDES QUALITATIVELY VERY DIFFERENT TYPES OF INFORMATION ON THE ENVIRONMENT
- SENSOR ARRAY VARIES WITH APPLICATION/MICROFABRICATION TECHNIQUES MANDATORY
- BASIS CHEMICAL SENSOR FEATURES:
 - RESPONSE TIME, SENSITIVITY, SELECTIVITY, STABILITY
 - BATCH FABRICATION, PROCESSING REPRODUCIBILITY, CONTROL OF STRUCTURE
 - TAILOR SENSOR SYSTEM FOR THE APPLICATION
- SUPPORTING TECHNOLOGIES NECESSARY
 - PACKAGING (OFTEN UP TO 70% OF OVERALL SENSOR COST)
 - SIGNAL CONDITIONING AND PROCESSING
 - SOFTWARE (E.G. NEURAL NET PROCESSING, MODELING)
 - POWER AND COMMUNICATION
- POSSIBLE STEPS NEEDED FOR BROAD INCLUSION OF SENSORS INTO INTELLIGENT SYSTEMS
 - “LICK AND STICK” TECHNOLOGY (EASE OF APPLICATION)
 - RELIABILITY
 - ORTHOGONALITY
 - CROSS-CORRELATION
 - REDUNDANCY

See for example: G. W. Hunter, C.C. Liu, D. Makel, Microfabricated Chemical Sensors For Aerospace Applications, MEMS Handbook, CRC Press LLC, ed. M. Gad-el-Hak, Ch. 22, 2001.



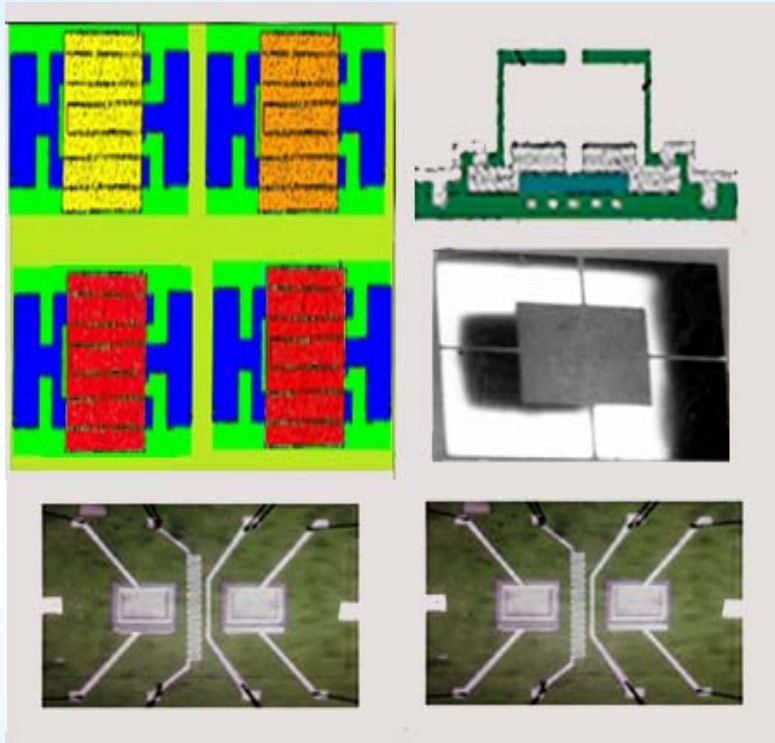
“LICK AND STICK” LEAK SENSOR SYSTEM DEMONSTRATION



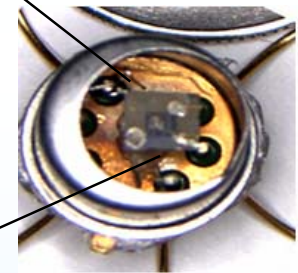
HIGH TEMPERATURE GAS SENSOR ARRAY HIGH TEMPERATURE ELECTRONIC NOSE

SnO₂ Resistor TiO₂ Resistor Electrochemical Oxygen Sensor

Selectively Filtered SnO₂ Resistors



SiC-Based Pressure Sensor



Metal-SiC Schottky diodes

Metal-Reactive Insulator SiC Schottky diodes

Makel Engineering, Inc.

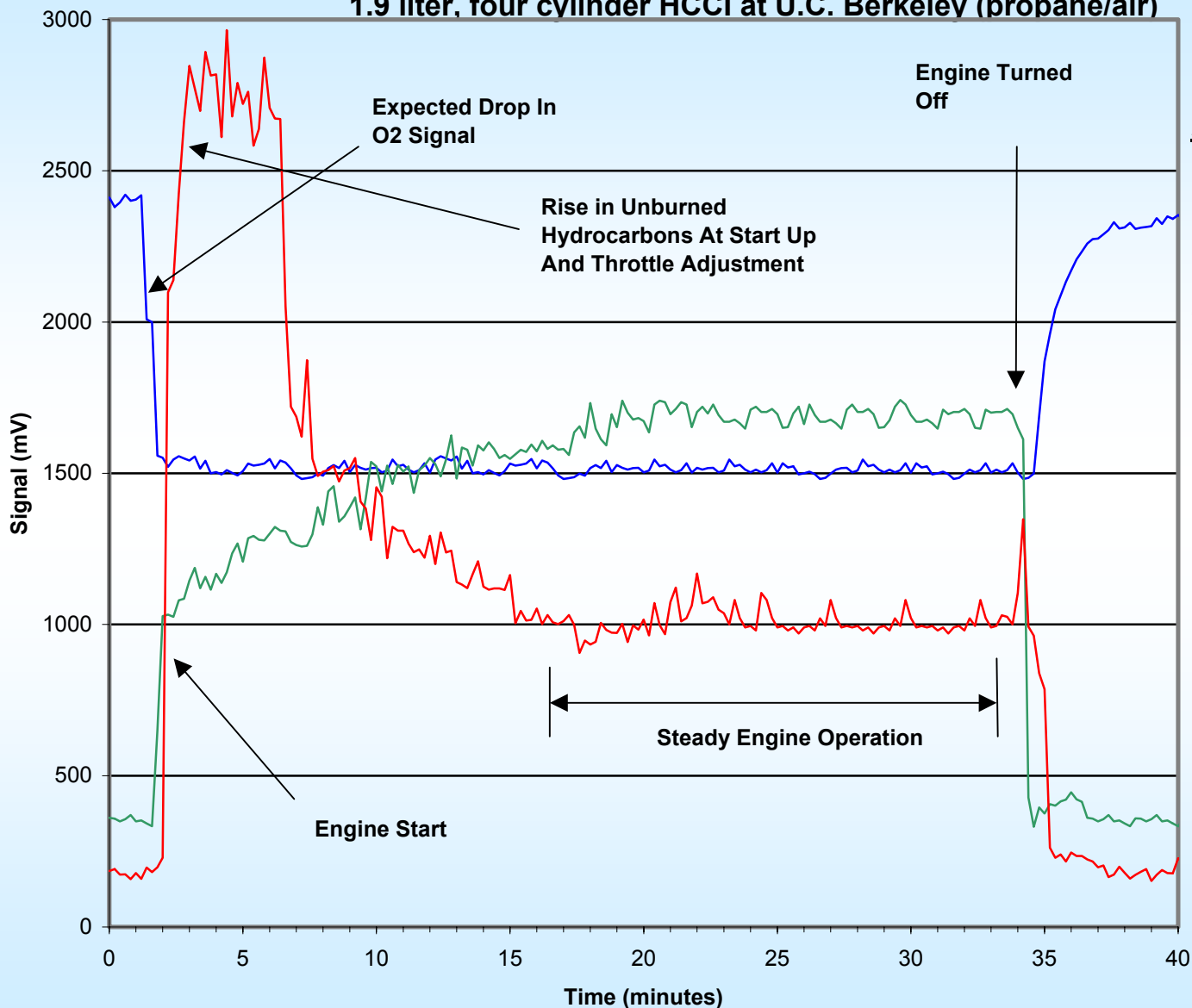
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Harsh Environment Demonstration Testing



1.9 liter, four cylinder HCCI at U.C. Berkeley (propane/air)



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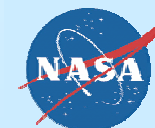
Exhaust Gas Temperature = 337 C
Phi= 0.35
O2=14%
NOx<5 PPM
CO =1400 PPM
UHC =1200 PPM

- Oxygen Sensor
- SnO2 Sensor
- SiC Hydrocarbon Sensor



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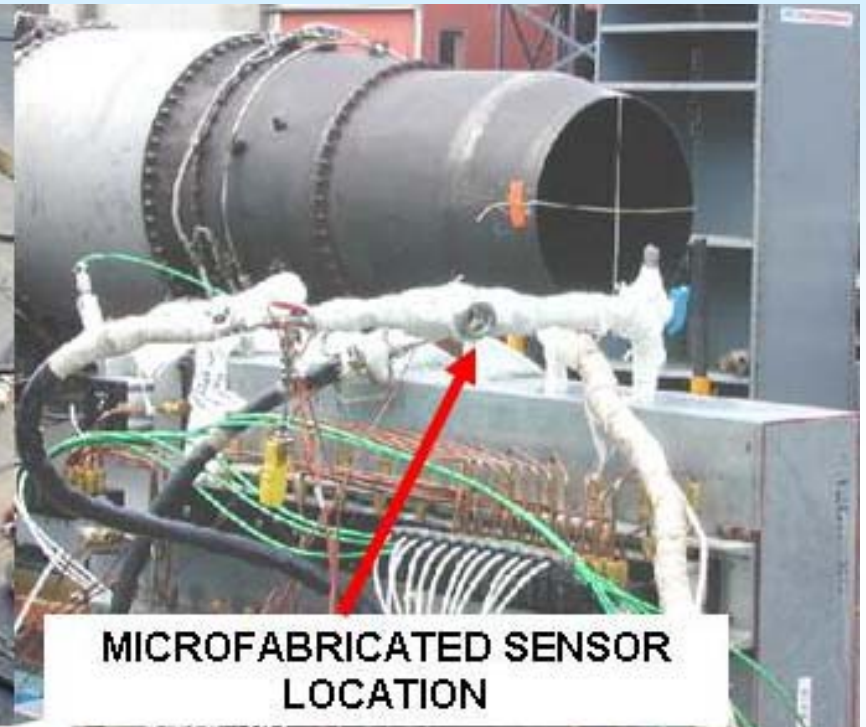
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MICRO SENSORS TESTED AT OUTLET OF THE JT-12 JET ENGINE



Rake Sampling System At The Outlet Of The JT-12 Jet Engine.



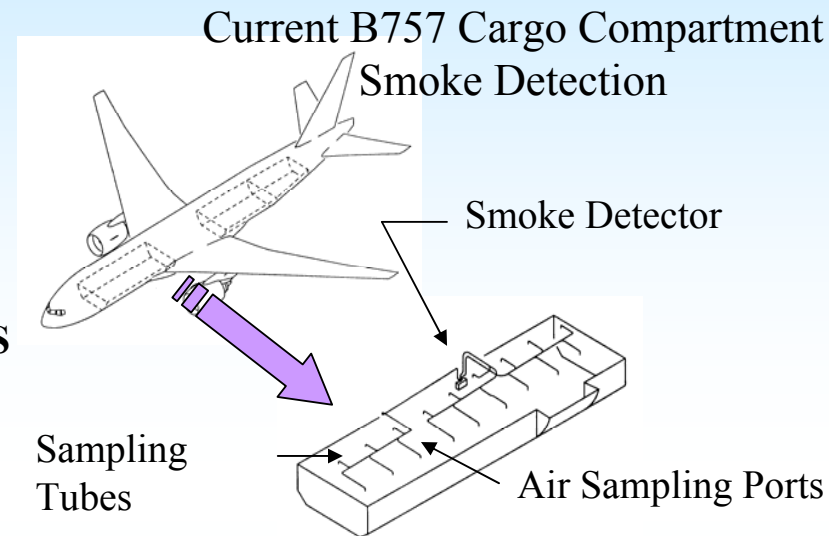
Location Of The Sensors In The Flow Stream Of The Rake

HIGH TEMPERATURE OPERATIONAL CAPABILITY AND OF THE SENSORS ALLOW PLACEMENT SIGNIFICANTLY CLOSER TO THE ENGINE OUTLET THAN TRADITIONAL EQUIPMENT.

Micro-Fabricated Gas Sensors for Low False Alarms

FEATURES

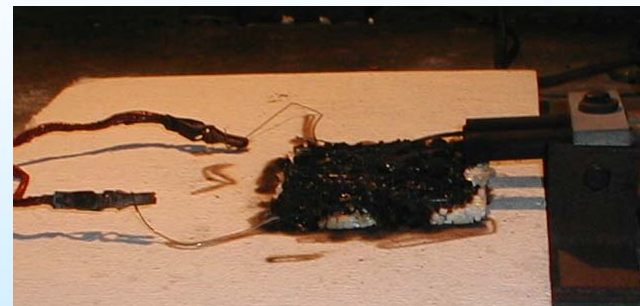
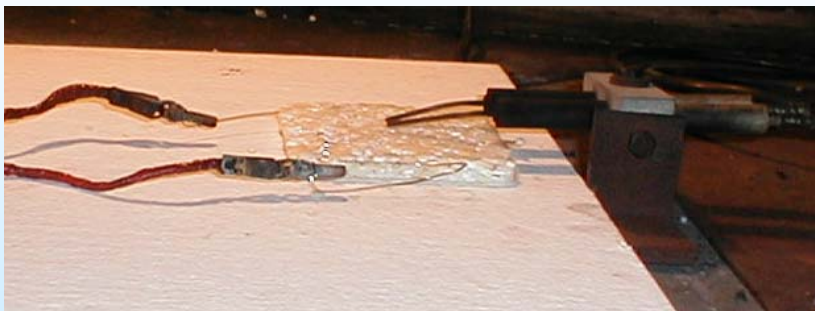
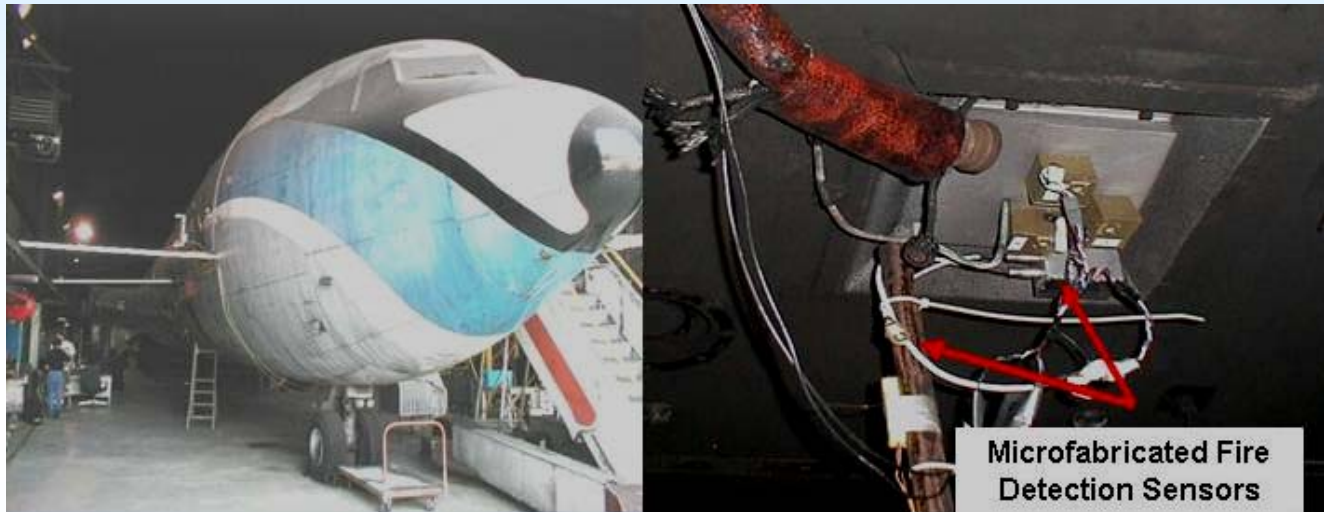
- **MICROFABRICATED GAS SENSOR ARRAY ESP. CO/CO₂**
 - **CENTRAL TO APPROACH**
 - **TWO APPROACHES TO CO₂ DETECTION**
 - **MINIMAL SIZE/WEIGHT/POWER**
- **CHEMICAL GAS SENSORS PROVIDE GASEOUS PRODUCT-OF-COMBUSTION INFORMATION**
 - **SENSOR ARRAY CAN DETECT RANGE OF GAS SPECIES**
 - **TO BE COMBINED WITH INTELLIGENT SOFTWARE FOR PATTERN RECOGNITION**
- **COMBINE WITH MICROPARTICULATE DETECTORS**
- **BENEFITS**
 - **DISCRIMINATE FIRES FROM NON-FIRES**



Particulate sensor contrasted with traditional macroscale classifier.



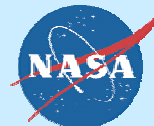
FAA Cargo Bay Fire Simulation Testing Boeing 707 luggage compartment and the FAA “Biscuit”



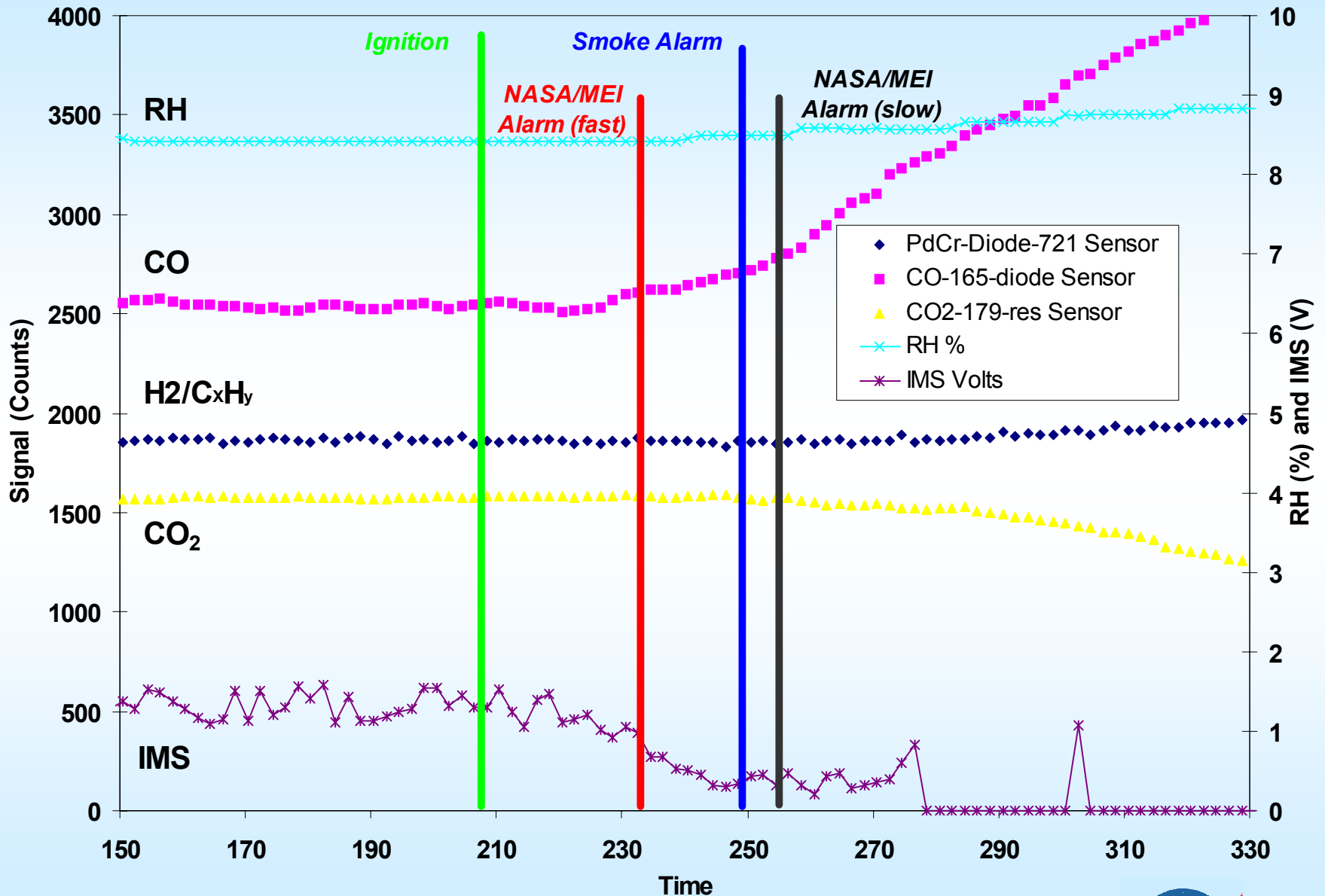
FAA Cargo Bay False Alarm Testing

No False Alarms

Test#	Detection System(s) Exposed	Exposed to	Test Duration (secs)	Generic Alarm Time (secs)	Alarm Time with Algorithm X (secs)	Alarm Time with Algorithm Y (secs)	Alarm Time with Algorithm Z (secs)
1	Generic/Makel	Dust		15	No Alarm	No Alarm	No Alarm
2	Generic/Makel	Dust		3	No Alarm	No Alarm	No Alarm
3	Generic/Makel	Dust		2	No Alarm	No Alarm	No Alarm
4	Generic/Makel	Dust		41	No Alarm	No Alarm	No Alarm
5	Generic/Makel	Dust		1	No Alarm	No Alarm	No Alarm
6	Generic/Makel	Dust		2	No Alarm	No Alarm	No Alarm
7	Generic/Makel	Dust		3	No Alarm	No Alarm	No Alarm
8	Generic/Makel	Dust		1	No Alarm	No Alarm	No Alarm
9	Generic/Makel	Dust		1	No Alarm	No Alarm	No Alarm
10	Generic/Makel	Dust		2	No Alarm	No Alarm	No Alarm
11	Generic	Water vapor	300	9			
12	Makel	Water vapor	340	N/A	No Alarm	No Alarm	No Alarm
13	Makel	Water vapor		N/A	No Alarm	No Alarm	No Alarm
14	Generic	Water vapor	20	3			
15	Generic	Water vapor	60	2			
16	Makel	Water vapor	60	N/A	No Alarm	No Alarm	No Alarm



FAA Cargo Bay Fire Testing



SUMMARY

- **AEROSPACE AND HARSH ENVIRONMENT APPLICATIONS REQUIRE A RANGE OF CHEMICAL SENSING TECHNOLOGIES**
- **NEW FAMILY OF GAS SENSOR TECHNOLOGY BEING DEVELOPED TO MEET THESE NEEDS USING:**
 - **MICROFABRICATION AND MICROMACHINING TECHNOLOGY**
 - **NANOMATERIALS**
 - **SiC-BASED SEMICONDUCTOR TECHNOLOGY**
- **TECHNOLOGY BEST APPLIED WITH STRONG INTERACTION WITH USER/TAILORED SENSOR FOR NEEDS OF APPLICATION**
- **A VARIETY OF SENSOR TYPES AND PLATFORMS BEING DEVELOPED**
- **SUPPORTING TECHNOLOGIES NECESSARY**
- **RESOLUTION OF A NUMBER OF TECHNICAL CHALLENGES: SENSOR ARRAYS**
 - **LEAK DETECTION**
 - **HIGH TEMPERATURE ELECTRONIC NOSE**
 - **FIRE DETECTION**
- **LONG-TERM: INTELLIGENT SYSTEMS**
 - **RELIABILITY**
 - **REDUNDANCY**
 - **ORTHOGONALITY**
 - **CROSS-CORRELATION**

